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Energy Research

DEVELOPMENT OF HIGH-SENSITIVITY OPTICAL METHODS FOR THE MONITORING OF INTERFACES

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INTRODUCTION



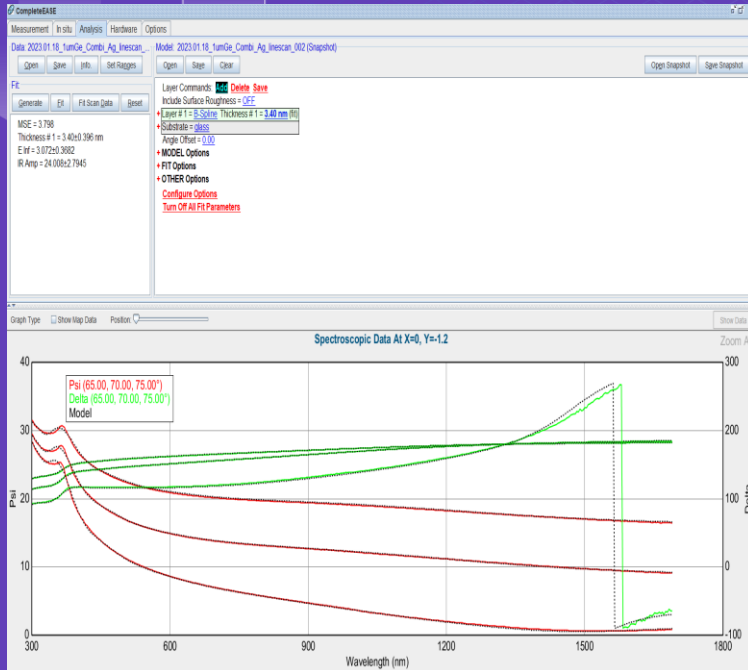
Ellipsometry Phenomenon

Ellipsometry measures the change of polarization of an incident beam caused by a sample for determining surface layers.

$$R_p/R_s = \tan(\Psi) e^{i\Delta} \quad (1)$$



IN-SITU ELLIPSOMETRY & OPTICAL MODELS



CompleteEASE User Interface

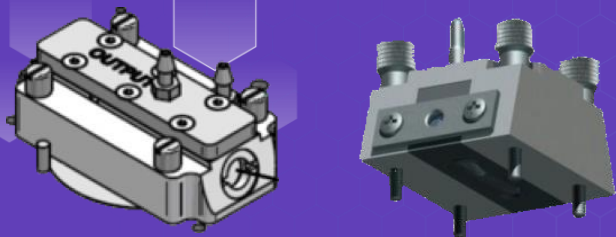
In Situ Spectroscopic Ellipsometry measures a sample "in position" as conditions are varied. It is also common to use in situ measurements to characterize optical constants during different process conditions.

With in situ capability, the sample can be characterized:

- ☐ Prior to Film Deposition for Accurate Substrate Characterization
- ☐ In Real-time for Thickness and Optical Constants Monitoring
- ☐ Before exposure to Air/Oxidation

The CompleteEASE software includes built-in models covering a wide range of typical samples that conveniently describe how to process the data to determine thin film properties. Real-time data acquisition is also possible to monitor and control the processes under investigation.

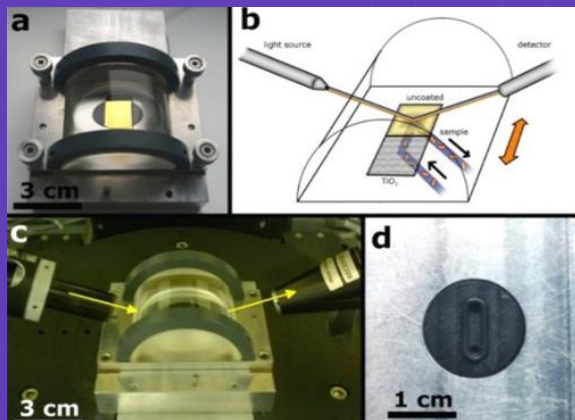
CONVENTIONAL FLOW CELL ELLIPSOMETRY



Flow-cells of 'through-liquid' configuration

Features of the conventional setup:

- ❑ Monitoring of the thickness of adsorbed layers
- ❑ Kinetics of adsorption
- ❑ Optical Constants (n, k)
- ❑ Surface Quality before and after processing
- ❑ Process Conditions that affect optical constants
- ❑ Material Properties that have an effect on optical constants

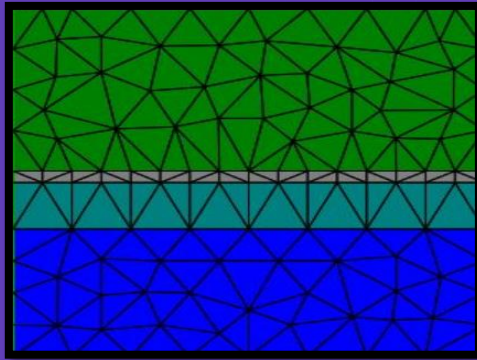


Kretschmann–Raether Flow cell

Total Internal Reflection Ellipsometry (TIRE) is a combination of internal reflection and ellipsometry. In the Kretschmann–Raether prism geometry, the prism is mounted on a flow cell for measurements in liquids. The surface in contact with the liquid is a thin metal film evaporated on a glass slide, which is in optical contact with the prism by an index matching liquid. [6]

JCMWAVE

JCMSuite is a software package with a focus on fast and highly accurate electromagnetic simulations for finite element analysis.^[1] It is based on the following modules:



JCM Modelled Kretschmann–
Raether Configuration

JCMSolve

Simulation engine

JCMControl

User Interface

JCMGeo

Finite Element mesh generator

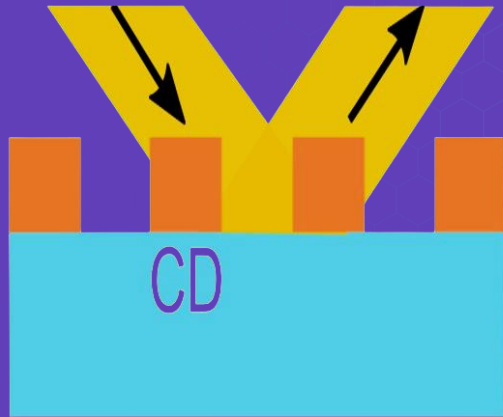
JCMView

Mesh & computed fields viewer

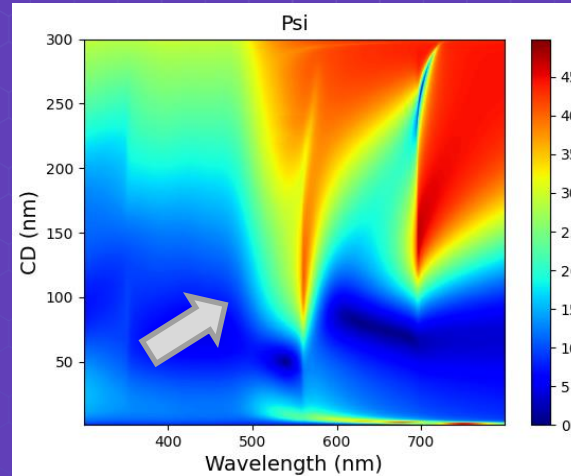
CONVENTIONAL CONFIGURATION

For our experiment, $d = 40$ nm Au on glass in reflection setup, i.e. air/Au-grating/glass, is modelled using JCMsuite. The parameters used are as follows:

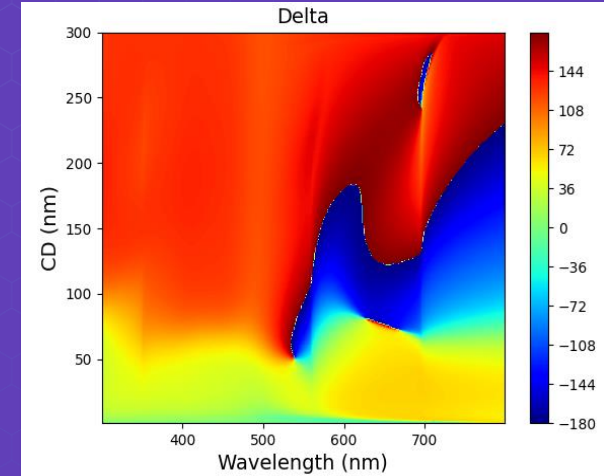
Angle of Incidence (AOI) = 60° , Period = 300 nm, Unit cell = 300 nm x 300 nm, Critical Dimension (CD): Au line width.



Optical configuration



Psi results obtained

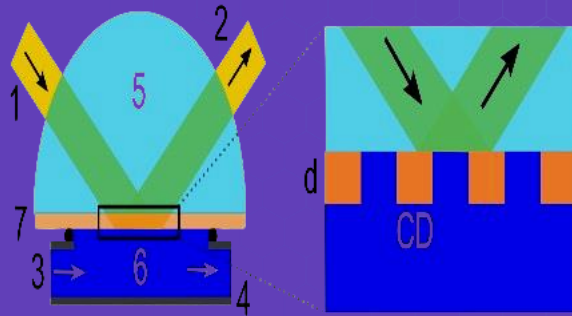


Delta results obtained

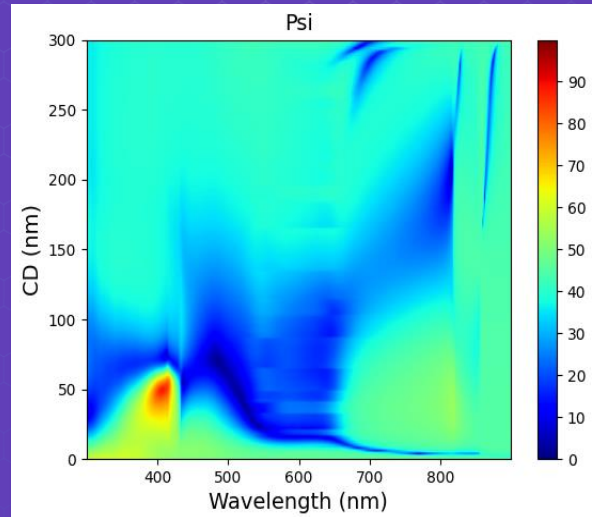
KRETSCHMANN-RAETHER CONFIGURATION

For our experiment, $d = 40$ nm Au on glass in Kretschmann-Raether setup, i.e. glass/Au-grating/water, is modelled using JCMsuite. The parameters used are as follows:

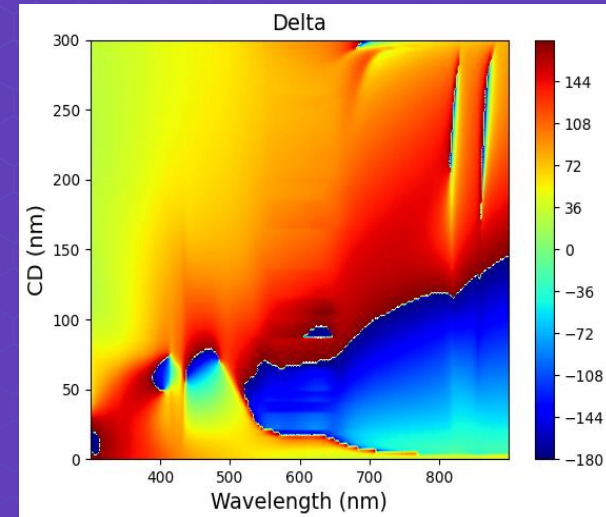
Angle of Incidence (AOI) = 75° , Period = 300 nm, Unit cell = 300 nm x 300 nm, Critical Dimension (CD): Au line width.



Optical configuration



Psi results obtained

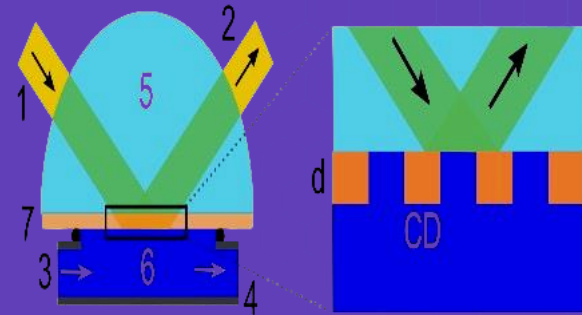


Delta results obtained

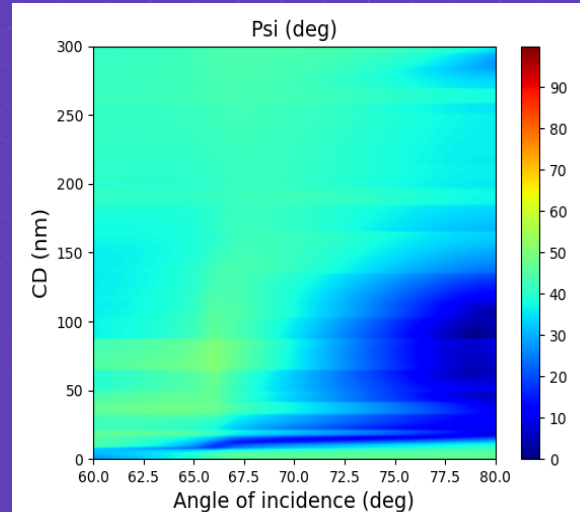
KRETSCHMANN-RAETHER CONFIGURATION

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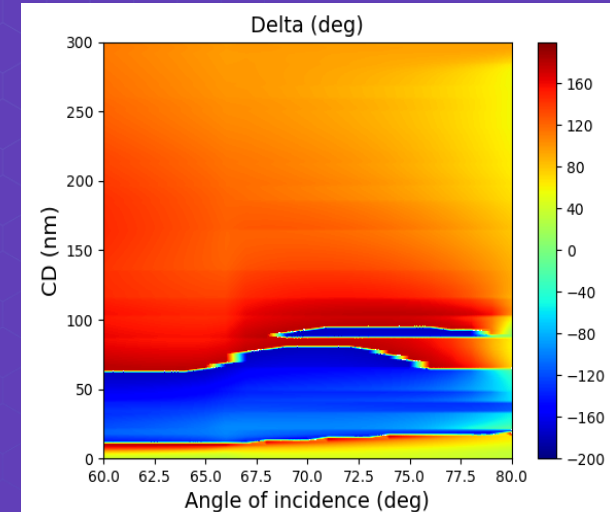
Angle of Incidence (AOI) = 75° , Period = 300 nm, Unit cell = 300 nm x 300 nm, Critical Dimension (CD): Au line width.



Optical configuration



Psi results obtained



Delta results obtained



PUBLICATIONS

No	Publication	IF	Total credit	MTMT ID	Personal credit
1	Deshabrato Mukherjee and Peter Petrik. "Real-Time Ellipsometry at High and Low Temperatures" . ACS Omega 8, no. 4 (2023): 3684–97. https://doi.org/10.1021/acsomega.2c07438 .	4.263	36	33570770	36
2	Deshabrato Mukherjee, Benjamin Kalas, Sven Burger, Gyorgy Safran, Miklos Serenyi, Miklos Fried, and Peter Petrik. "Nanostructures for In-Situ Surface-Enhanced Kretschmann-Raether Ellipsometry" . Photonic Instrumentation Engineering X, SPIE, 2023. https://doi.org/10.1117/12.2649080 .	0.367	24	33699389	24
3	Zoltan Labadi, Csaba Bakos, Mate Szucs, Attila Bonyar, Deshabrato Mukherjee, Hajnalka Jankovics, Ferenc Vonderviszt, and Peter Petrik. "Ellipsometry Monitoring of Sensor Processes Based on Gold Nanoparticle Bonded Proteins." Colloidal Nanoparticles for Biomedical Applications XVIII, SPIE, 2023. https://doi.org/10.1117/12.2649990 .	0.367	24	33724105	24
4	D.G Merkel, K. Sájerman., T. Váczi, S. Lenk, G. Hegedűs, S. Sajti, A. Németh, M.A. Gracheva, P. Petrik, D. Mukherjee, Z.E. Horváth, D.L. Nagy, A. Lengyel. "Laser irradiation effects in FeRh thin film" . Materials Research Express, 10 (7), Art. no. 076101, 2023. https://doi.org/10.1088/2053-1591/ace4a3	2.270	36	34536298	18
5	Chou Ta-Shun, Saud Bin Anooz, Rajmund Grüneberg, Jana Rehm, Arub Ahktar, Deshabrato Mukherjee, Peter Petrik, Andreas Popp. "In - situ spectral reflectance investigation of heteroepitaxial grown β-Ga₂O₃ thin films on c-plane Al₂O₃ via MOVPE process" (2024) Applied Surface Science. https://doi.org/10.1016/j.apsusc.2024.159370	7.146	36	34503364	18
6	Saud Bin Anooz, Peter Petrik, Yankun Wang, Deshabrato Mukherjee, Martin Schmidbauer, and Jutta Schwarzkopf "Dielectric function and interband critical points of compressively strained ferroelectric K_{0.85}Na_{0.15}NbO₃ thin film with monoclinic and orthorhombic symmetry" . Optics Express, Vol. 32, Issue 9, pp. 15597-15609, (2024), https://doi.org/10.1364/OE.520426	3.605	36	34791151	18



CURRICULUM ACTIVITIES

No	Neptun Code	Subject	Professor	Semester
1	DATBESZ6ND	Research Report VI.	Dr. Recskiné Dr. Borsa Judit Ilona	6
2	DATKUTP6ND	Research Project VI.	Dr. Recskiné Dr. Borsa Judit Ilona	6

- Reviewing the related literature of ellipsometry and finite modelling for my future publications and progress.
- I was also involved in investigations combining spectroscopic ellipsometry with cyclic voltammetry.
- I was able to conduct various measurements on new samples from Leibniz-Institut für Kristallzüchtung (IKZ), Berlin using the J.A. Woollam M-2000 DI ellipsometer in combination of TSEL-1000 heat cell stage ranging up to temperatures of 1000 °C. The samples were also measured with the J.A. Woollam Mark II IRS ellipsometer.
- Research article titled **“Optical and sensing properties of thermally generated gold nanoislands created by the annealing of layers with graded thickness”** was resubmitted post revisions for publication.
- Self-development of a novel non-depolarizing Kretschmann-Raether (KR) flow cell for ellipsometry and the preliminary set of sensing measurements of heavy metals were done which will be followed up with further studies and results for a publication. Certain experiments have already been completed for heavy metal sensing in an optical flow cell using monomers of genetically engineered flagellar filaments.
- The first grating structures that arrived from POLight project last semester was measured using M-2000DI SE and these set of experiments were mirrored to study the modeling capabilities for periodic plasmonic nanostructures on JCMSuite. Currently for the modelled grating structure, simulations are being carried out with modification of all the grating parameters such as Critical Dimension (CD), thickness of Au, Wavelength, Angle of Incidence(AOI) and Pitch.



CONFERENCES & FUTURE WORK

CONFERENCE: Presented my work titled **“Sensing properties of gold nanoparticles created by combinatorial magnetron sputtering & annealing”** at the 2024 E-MRS Spring Meeting, May 27-31, 2024, Strasbourg, France.

- Submission of review article titled **“In-situ ellipsometry at solid-liquid interfaces”** post the ISCMP 2024 conference.
- Final analysis of IKZ samples with SE and IRSE characterization along with heat treatment whose results will lead to an upcoming publication this year.
- Further experiments on the self-developed novel non-depolarizing KR flow cell for sensing measurements of heavy metals and results for another publication.
- Experiments related to heavy metal sensing in an optical flow cell using monomers of genetically engineered flagellar filaments.
- New grating samples from the POLight project has arrived recently which will be measured using M-2000DI SE and these will be again mirrored to study the modeling capabilities on JCMSuite. After the modulation of the grating parameter results obtained in this semester, it will be followed with simulations and experiments for interactions with bio-molecules for determining of sensing with and overlayer present. This will be a work which I propose to publish in a D1 journal before the submission of my thesis.
- Presentations at the ISCMP-2024 conference in Bulgaria followed by another presentation at EOSAM-2024 conference in Italy.
- Most of my research work over the last couple of years will be presented at the 10th International Conference on Spectroscopic Ellipsometry, ICSE-10 which will be held next year in USA.

GANTT CHART

Gantt Chart		Planned	2021	2022		2023		2024		2025	
		Current stage	I	II	I	II	I	II	I	II	
Literature review											
FEM Modelling											
Nanoparticles & Grating Measurements											
Sensing Measurements & Analysis											
Publication and conference											
Thesis writing											



ACKNOWLEDGEMENTS

- This research was funded by the National Research, Development and Innovation Office (NKFIH) in Hungary via the Grants Nr. K-146181, K-143216, K-134258 and PD 146479.
- The work in the frame of the 20FUN02 “POLight” project has received funding from the EMPIR programme co-financed by the Participating States and from the European Union’s Horizon 2020 research and innovation programme.
- Project no. TKP2021-EGA04 has been implemented with the support provided by the Ministry of Innovation and Technology of Hungary from the National Research, Development and Innovation Fund, financed under the TKP2021 funding scheme.
- On behalf of the ‘MFA-Fotonika-1’ project we are grateful for the possibility to use HUN-REN Cloud.
- Project no. C1792954 has been implemented with the support provided by the Ministry of Culture and Innovation of Hungary from the National Research, Development and Innovation Fund, financed under the KDP-2021 funding scheme. A.P. acknowledges the János Bolyai Research Scholarship from the Hungarian Academy of Sciences.

REFERENCES

- www.jcmwave.com/docs/qd-uki.co.uk/wp-content/uploads/2019/07/In-Situ-EllipsometryJ-A-Woollam-In-Situ-Brochure-small.pdf
- Matthias Wurm, Tobias Grunewald, Sven Teichert, Bernd Bodermann, Johanna Reck, & Uwe Richter, "Some aspects on the uncertainty calculation in Mueller ellipsometry"; **Optics Express** Vol. 28, Issue 6 pp. 8108-8131, (2020)
- Postava, K., Maziewski, A., Yamaguchi, T., Ossikovski, R., Visnovsky, S., & Pistora, J. "Null ellipsometer with phase modulation"; *Optics Express*, 12(24), 6040, (2004).
- Chen, Y., Meng, Y., & Jin, G. "Optimization of off-null ellipsometry for air/solid interfaces"; *Applied Optics*, 46(35), 8475, (2007).
- Nador, J., Kalas, B., Saftics, A., Agocs, E., Kozma, P., Korosi, L., ... Petrik, P. "Plasmon-enhanced two-channel in situ Kretschmann ellipsometry of protein adsorption, cellular adhesion and polyelectrolyte deposition on titania nanostructures"; *Optics Express*, 24(5), 4812, (2016).
- Arwin, H., Poksinski, M., & Johansen, K. "Total internal reflection ellipsometry: principles and applications"; *Applied Optics*, 43(15), 3028, (2004).
- Hiroyuki Fujiwara, "Spectroscopic Ellipsometry Principles and Application" Japanese Edition, Copyright 2003, ISBN 4 621 07253 6, Published by Maruzen Co. Ltd, Tokyo, Japan



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